

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	19782	(electrode pad) and (particle core) with (metal conductive) same (coating insulating)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 09:49
L2	8245	(electrode pad) same (particle core) with (metal conductive) same (coating insulating)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 09:50
L3	1824	(electrode pad) same (particle core) with (metal conductive) same (coating insulating) and matrix	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 09:51
L4	73	(electrode pad) same (particle core) with (metal conductive) same (coating insulating) and matrix and (ESD EOS electrical adj overstress electrostatic adj discharge)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 09:54
L5	2	anistropic adj (adhesive layer film) same (electrode pad)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 09:54
L6	30	anistropic adj3 (adhesive layer film) same (electrode pad)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 09:54
L7	28036	particle with (adhesive layer film) same (electrode pad)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 09:56
L8	2427	(particle core) with (metal conductive) same (coating insulating) adj3 (adhesive layer film) same (electrode pad)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 10:12
L9	24	(particle core) with (metal conductive) same (coating insulating) adj3 (adhesive layer film) same (electrode pad) and (EOS ESD electrical adj overstress electrostatic adj discharge)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 09:58

L10	875	(particle core) with (metal conductive) same (non adj conductive coating insulating) adj3 (adhesive layer film) same (electrode pad) and polymer\$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 10:11
L11	3	("6613383") or ("6713177") or ("6913827").PN.	USPAT	OR	OFF	2005/10/03 10:06
L12	1	(particle core) with (metal conductive) same (non adj conductive coating insulating) adj3 (adhesive layer film) same (electrode pad) and polymer\$3 and atomic adj3 deposit\$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 10:14
L13	8030	(particle core) with (metal conductive) same (coating insulating) adj3 (adhesive layer film) same (electrode pad) atomic adj3 deposit\$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 10:13
L14	6	(particle core) with (metal conductive) same (coating insulating) adj3 (adhesive layer film) same (electrode pad) and atomic adj3 deposit\$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 10:13